

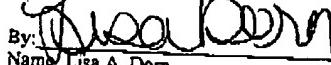
SEP 19 2006

S/N 10/804610

PATENT

Applicant: KITAOKA Examiner: TU TU V. HO
 Serial No.: 10/804610 Group Art Unit: 2818
 Filed: March 18, 2004 Docket No.: 10873.1420US01
 Title: METHOD OF MANUFACTURING GROUP III NITRIDE SUBSTRATE
 AND SEMICONDUCTOR DEVICE

CERTIFICATE UNDER 37 CFR 1.6(d):
 I hereby certify that this paper is being transmitted by facsimile to the U.S. Patent and Trademark Office on September 19, 2006.

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